



520.41003X00

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Yoshinobu KIMURA, et al.

Application No.: 10/019,407

Filed: March 25, 2002

For: POLYCRYSTALLINE SEMICONDUCTOR THIN FILM
SUBSTRATE, MANUFACTURING METHOD OF THE SAME,
SEMICONDUCTOR DEVICE AND ELECTRONIC DEVICE

Art Unit: 2813

Examiner: L. M. MENZ

**SUBMISSION INCLUDING AMENDMENT
PURSUANT TO 37 C.F.R. §1.114**

Mail Stop: Amendment/RCE

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

September 11, 2008

Sir:

This Amendment is being filed as a submission in connection with a Request for Continued Examination (RCE), in accordance with 37 C.F.R. §1.114, which is further to the filing of the Notice of Appeal on February 11, 2008, and is responsive to the outstanding Final Office Action, dated September 10, 2007. (An RCE transmittal along with a Petition for Extension of Time covering the fifth month extended time period for filing the submission and an authorized credit card payment for covering the fee amount directed thereto are enclosed.) Please amend the above-identified application as listed below and as set forth on the following pages:

Amendments to the Claims; and

Remarks are included following the amendments. (An Appendix including Sketches (a, b and c) are attached to the Remarks.)